

**PATENT NUMBER and
ISSUE DATE**

10/074354
02/11/02

U.S. UTILITY Patent Application

APPL NUM 10C74354	FILING DATE 02/11/2002	CLASS 427	SUBCLASS 568	GAU 131 4762	EXAMINER JADESSE
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**APPLICANTS: Scheer Craig; Stover John;

**CONTINUING DATA VERIFIED:
THIS APPLN CLAIMS BENEFIT OF 60/267,613 02/09/2001

** FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH <input checked="" type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiners's initials		<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO SCATP001
TITLE : Particle deposition system with enhanced speed and diameter accuracy U.S.DEP.T. OF COMM./PAT. & TM-PTO-436L(Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figa.Drwg.
TERMINAL DISCLAIMER		PREPARED FOR ISSUE		
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